

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



APPLICANT: Menon et al.

GROUP: 1756

SERIAL NO: 10/677,804

EXAMINER: John A. McPherson

FILED: October 2, 2003

FOR: SYSTEM AND METHOD FOR HOLOGRAPHIC FABRICATION AND
REPLICATION OF DIFFRACTIVE OPTICAL ELEMENTS FOR
MASKLESS LITHOGRAPHYCommissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CHANGE OF CORRESPONDENCE ADDRESS

Applicant's representative requests that the correspondence address for the above application be changed to:

Matthew E. Connors, Esq.
Gauthier & Connors, LLP
225 Franklin Street, Suite 2300
Boston, MA 02110

Respectfully submitted,

William E. Hilton
Registration No. 35,192
Gauthier & Connors, LLP
225 Franklin Street, Suite 2300
Boston, Massachusetts 02110
Telephone: (617) 426-9180
Extension 111

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Meghan H. Carr
Date